



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:

Inventor: Hyungsoo Choi

Application No.: 10/664,431

Filed: September 19, 2003

NANOSTRUCTURES INCLUDING A METAL

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) Before the Examiner
) Kelly M. Stouffer
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) Group Art Unit:
)
)
)
)

REPLY TO EXAMINER'S REASONS FOR ALLOWANCE

Mail Stop: ISSUE FEE
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

This reply accompanies the payment of the issue fee. In response to the Examiner's Reasons for Allowance, please consider the following. Part B of Fees Transmittal Form PTOL-85 and a Credit Card Payment Form for the requisite Issue fee are included.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope on **January 16, 2008**, addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature: _____

Printed Name: L. Scott Paynter



REMARKS

The applicant thanks the Examiner for the allowance of the present application, and offers the following comments for entry into the record. The reasons for allowance appear to maintain that the Ross et al. reference discloses certain freestanding features recited in some the claims -- instead it appears this reference has been solely overcome on the basis of the declaration. To the extent such is the case, the applicant respectfully reiterates that the Ross et al. reference lacks such features as further explained in the prior office action responses. In addition to the points set forth in the reasons for allowance, the claims are patentable over the art of record for various other reasons as explained in the prior office action responses, but are not repeated here for the sake of brevity.

Respectfully Submitted,

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